



US0803438;LSP/ehs:189038

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C. Moore

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IN THE UNITED STATES PATENT OFFICE

In re patent application of:

Rao V. Annapragada

Application No. 09/902,056

Filed: July 9, 2001

A METHOD OF IMPROVING ADHESION OF CAP OXIDE TO NANOPOROUS SILICA FOR INTEGRATED CIRCUIT FABRICATION

Before the Examiner

Asok K. Sarkar

Group Art Unit 2829

October 30, 2002

RESPONSE TO OFFICE ACTION

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated 30 July 2002, please consider the following.

Please charge any further extensions of time, other fees due or credit any overpayment to Deposit

Account No. 23-3030, but not to include issue fees.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on:

Date of Deposit: 30 October 2002

Name of Registered Representative: L. Scott Paynter

Signature:

Date of Signature: 30 October 2002

Response to Office Action
Application No. 09/902,056
Inventor(s): Rao Annapragada
Filed: July 9, 2001
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